

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/632,011	SUBIRADA ET AL.
	Examiner Hai C. Pham	Art Unit 2861 •

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
347	19	11/19/2005	HP
PGPub Text Search		11/19/2005	HP